

Notice of References Cited	Application/Control No. 10/673,890	Applicant(s)/Patent Under Reexamination ABE, YASUHIRO	
	Examiner Khai M. Nguyen	Art Unit 2687	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2002/0058527 A1	05-2002	Kawasaki et al.	455/550
*	B	US-6,466,202 B1	10-2002	Suso et al.	345/169
*	C	US-6,731,959 B1	05-2004	Kumagai et al.	455/575.3
*	D	US-6,662,244 B1	12-2003	Takahashi, Masahiro	710/14
*	E	US-6,862,459 B2	03-2005	Sawada et al.	455/550.1
*	F	US-2005/0107138 A1	05-2005	SanGiovanni, John	455/575.1
*	G	US-2002/0033798	03-2002	Nakamura et al.	345/156
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	V	
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	X	

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